Supporting Information

Radiative defects in chloride-activated CdSe thin films

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1. Experimental section

Cadmium selenide (CdSe) films were deposited on a TEC12D glass substrate received from Pilkington (NSG Group). The glasses were cleaned using a Micro-90 detergent under ultrasonic cleaning and a few rinses with deionized water. Source material for the CdSe was received from 5N plus. CdSe films was deposited using a thermal evaporation technique at a base pressure of 10^{-6} Torr at a substrate temperature of $400\,^{\circ}$ C. CdSe film was cadmium chloride (CdCl₂) treated with saturated CdCl₂ solution in methanol as reported previously [1]. For a sample of 3"x3", CdCl₂ solution of 0.6 mL was drop-casted, and let it dry in the fume hood. Then, the film was heated at $450\,^{\circ}$ C for 40 mins in a dry-air environment. CdSe film was rinsed with methanol, dried with dry-air followed by other characterizations. The optical absorption spectra of CdSe films were determined from measured reflectance and transmittance using a PerkinElmer Lambda 1050 spectrophotometer.

The surfaces and cross-sectional images of the CdSe films were captured using a Hitachi S-4800 UHR scanning electron microscope (SEM). X-ray diffraction patterns were obtained using a Rigaku Ultima III X-ray diffractometer equipped with a Cu k-alpha source operating at a 40 kV accelerating voltage and a current of 44 mA.

Photoluminescence (PL) and time-resolved PL (TRPL) were measured with the sample mounted in a closed-cycle helium cryostat (Advanced Research Systems DE-202-AI) equipped with a LakeShore 335 temperature controller. The cryostat chamber was evacuated for 30 min using a Pfeiffer TSH-071-E pump before cooling with an ARS-2HW helium compressor. Continuous-wave PL excitation was provided by a Spectra-Physics Excelsior 532 nm laser and a Thorlabs 785 nm laser diode. Pulsed TRPL excitation was provided by a Fianium supercontinuum source, with 532 nm or 785 nm wavelengths selected by an acousto-optic tunable filter. Long-pass filters (665 nm for 532 nm excitation and 850 nm for 785 nm excitation) were used to block the laser excitations reaching the detector. Spectra were collected with LN₂-cooled detectors, a Si CCD and a Ge array, and corrected for system response using a calibrated tungsten—halogen lamp. Unless otherwise specified, the excitation fluence was fixed at 5×10^{17} photons cm⁻² s⁻¹ for temperature-dependent PL and TRPL. Injection-dependent PL was obtained by varying the fluence between 5×10^{15} and 5×10^{18} photons cm⁻² s⁻¹ using neutral-density filters. Further details of the PL/TRPL system are described elsewhere [2-3].

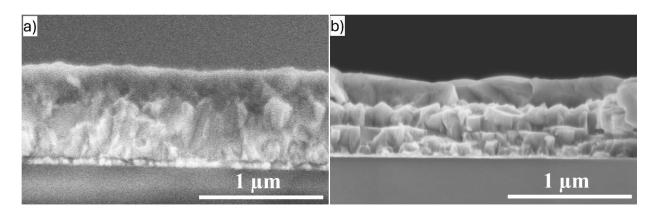
Hyperspectral micro-photoluminescence (PL) maps were recorded using a confocal Raman/PL microscope (WITec alpha300 RAS) equipped with a quasi-tunable white light laser source (NTK Photonics) with excitation wavelength 520 nm and laser power 130 μ W [4-5]. A long-pass filter with a cutoff of 550 nm was placed before the detector to filter the signal from the laser. Spectral data were captured through a 100x objective lens (NA/0.9) and analyzed using a UHTS 300 VIS spectrometer. An X-Y piezo flexure stage was used for the sample lateral scanning for obtaining the PL spectral maps in the areas: 2.5 × 2.5 μ m2, scan speed 26 s/line, 512 × 512 pixels per image. PL maps were recorded and processed by WITec Control 6.1 and WITec Project 6.1 software.

2. DFT calculation details

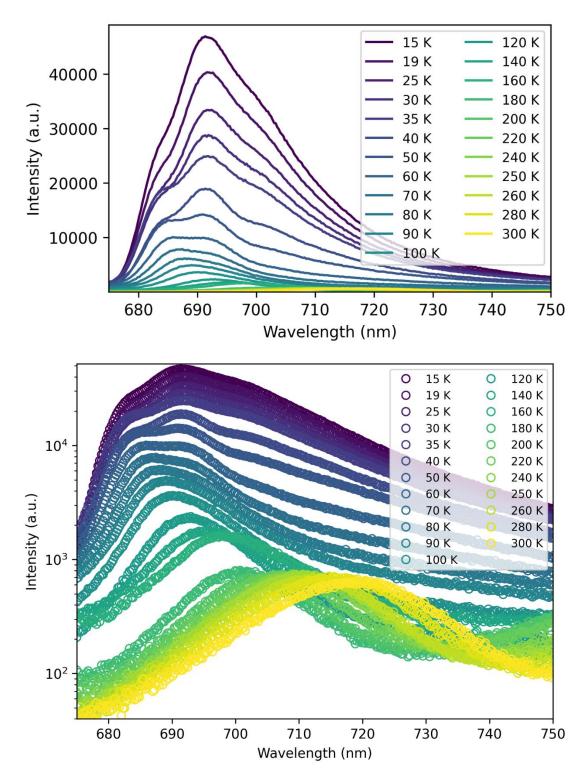
All first-principles calculations were performed using the VASP code [6-8] with the projector-augmented wave (PAW) method [9]. The zinc-blende phase of CdSe, containing two atoms per unit cell, was adopted as the reference structure. A plane-wave cutoff energy of 300 eV and a Γ -centered 4×4×4 Monkhorst–Pack k-point mesh were used for total-energy and electronic-structure calculations. The Heyd–Scuseria–Ernzerhof (HSE06) hybrid functional [10-11] with 32% exact exchange was employed to reproduce the experimental band gap, while the PBE functional [12] with a denser Γ -centered 16×16×16 mesh was used for dielectric constant calculations. Structural optimizations of both bulk and defect supercells were performed until the residual forces on all atoms were less than 0.01 eV/Å.

Defect calculations were carried out in a 64-atom supercell, constructed from a 2×2×2 expansion of the conventional cubic CdSe unit cell. A Γ-centered 2×2×2 k-point mesh was used for Brillouin-zone sampling. Finite-size effects in charged defect calculations were corrected using the extended Freysoldt–Neugebauer–Van de Walle (FNV) scheme [13-14]. Optical transition energies were further corrected with the GKFO scheme [15], while Lany–Zunger 2/3 scaling of the point-charge correction [16] was applied to all charge corrections. The *doped* [17] and *pydefect* [18] packages were employed to assist defect energetics and analysis.

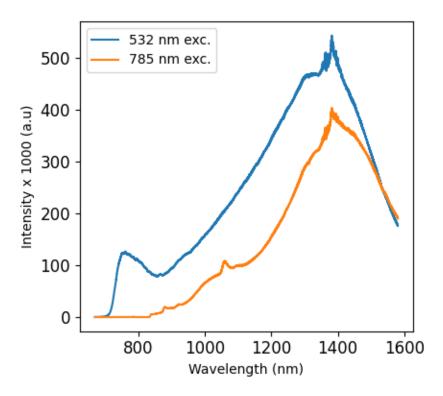
3. Supplementary Figures



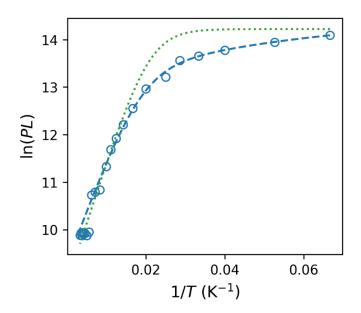
Supplementary Fig. 1. Cross-sectional SEM images of (a) as-deposited and (b) CdCl2 treated CdSe thin film. Estimated film thickness is about 300 nm.



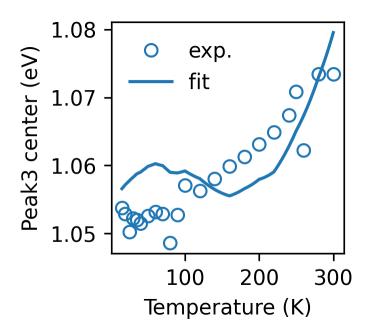
Supplementary Fig. 2. Temperature-dependence of near-edge band (Peak 1) measured from 15 K--300 K under 532 nm laser excitation, given in linear-linear and linear-log scale. Three peaks (681, 690, 703 nm) present below 80 K, taken over by 681 nm above 80 K and the peak center red-shifts 720 nm by 300 K.



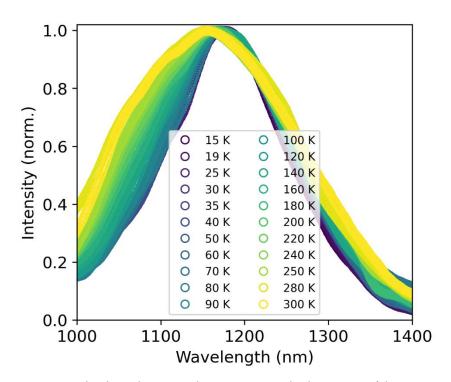
Supplementary Fig. 3. PL spectra of as-deposited CdSe film measured at 10 K under 532 nm and 785 nm excitations (fluence: $5x10^{18}$ photons/cm²/s). The peak around 775 nm is the near-edge band. The peak-like noise between 1370-1390 nm is from the noise in the spectral correction. No PL signal was detected at 300 K.



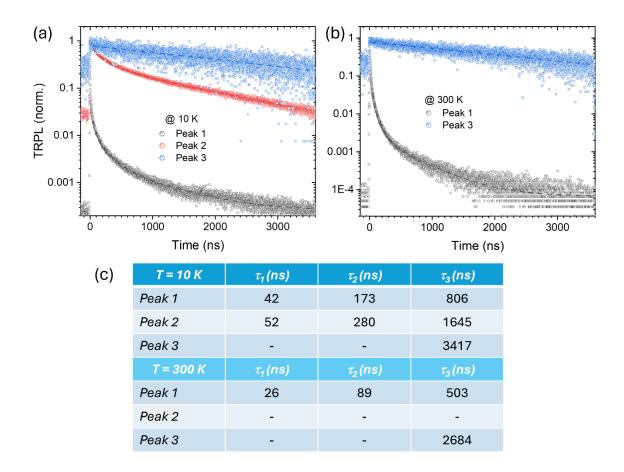
Supplementary Fig. 4. Integrated spectral weight of Peak 1 (symbols) fitted with a single Arrhenius model (green dotted line) and a double Arrhenius model (blue dashed line). The single Arrhenius fit is applied for T > 120 K, while the double Arrhenius fit covers the entire temperature range of 15-300 K. The double-Arrhenius fit yields activation energies $E_a = 19.3 \text{ meV}$ and $E_b = 2.6 \text{ meV}$; the single-Arrhenius fit yields $E_a = 22.1 \text{ meV}$.



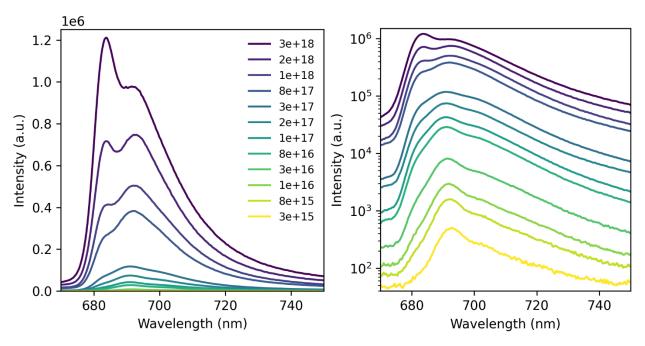
Supplementary Fig. 5 Temperature dependence of the Peak 3 center energy, fitted using conventional donor—acceptor pair expressions that account for the bandgap energy, donor energy, acceptor energy, and a Coulomb term [19].



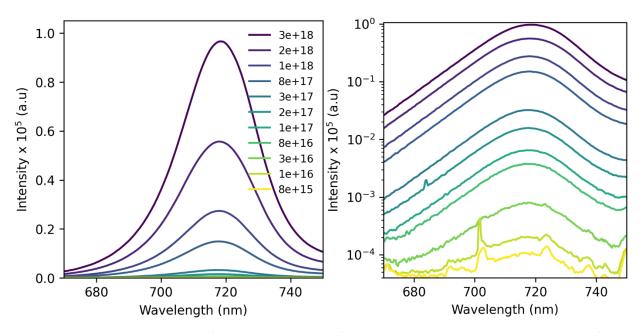
Supplementary Fig. 6. Peak 3 broadening with temperature: higher energy (shorter wavelength) side contributes more to the broadening.



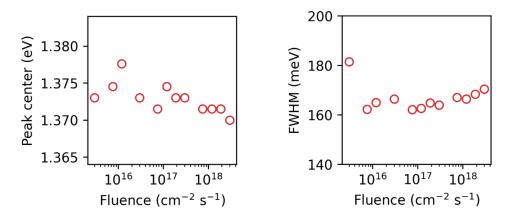
Supplementary Fig. 7 Normalized TRPL decay traces measured at (a) 10 K and (b) 300 K under 532 nm laser excitation, and (c) the extracted lifetimes obtained from single-exponential fits (Peak 3) and multi-exponential fits (Peaks 2 and 3).



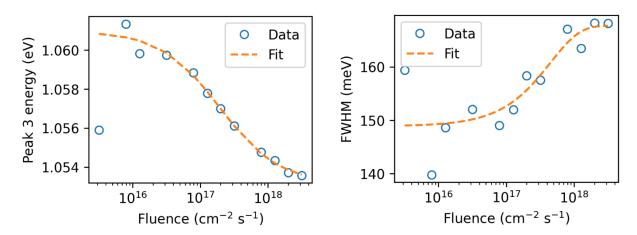
Supplementary Fig. 8. Excitation fluence dependence of peak 1 at 10 K. Fluence is given in units of photons $cm^{-2} s^{-1}$.



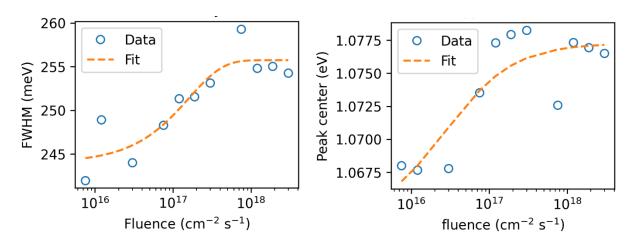
Supplementary Fig. 9. Excitation fluence dependence of peak 1 at 300 K. Fluence is given in units of photons $cm^{-2} s^{-1}$.



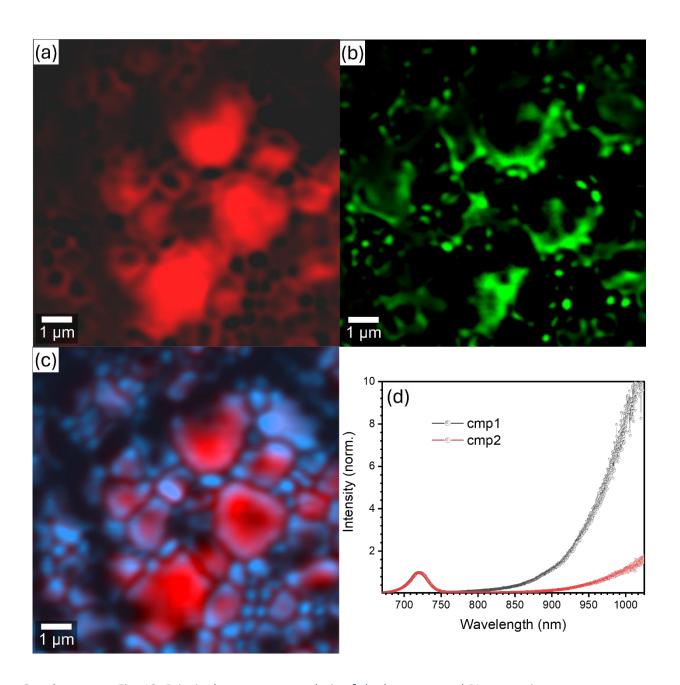
Supplementary Fig. 10. Excitation fluence dependence of peak 2 center energy (left panel) and width (right panel) at 10 K.



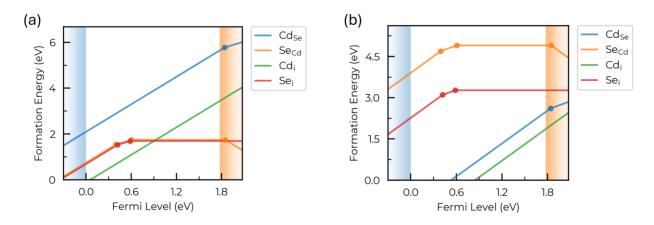
Supplementary Fig. 11. Excitation fluence dependence of peak 3 center energy (left panel) and width (right panel) at 10 K.



Supplementary Fig. 12. Excitation fluence dependence of peak 3 center energy (left panel) and width (right panel) at 300 K.



Supplementary Fig. 13. Principal component analysis of the hyperspectral PL map using two component spectra (d). The resulting distribution maps correspond to component 1 (a) and component 2 (b), with (c) showing the overlaid map of components 1 and 2.



Supplementary Fig. 14. Defect formation energies of CdSe under (a) Se-rich and (b) Cd-rich conditions.

4. Supplementary Tables

Table I: Sub-band gap transitions and emission energies of point defects in CdSe.

Transition	E_{PL} (eV)
$V_{Se}^+ + h_{VBM}^+ \rightarrow V_{Se}^{+2}$	1.26
$[V_{Cd} - Cl_{Se}]^0 + e_{CBM}^- \rightarrow [V_{Cd} - Cl_{Se}]^-$	0.92
$V_{Cd}^- + e_{CBM}^- \rightarrow V_{Cd}^{-2}$	0.70
$Se_i^+ + e_{CBM}^- \rightarrow Se_i^0$	0.71
$Se_{Cd}^+ + e_{CBM}^- \rightarrow Se_{Cd}^0$	0.57

5. Supplementary References

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